

MAR 03 2006

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**SCULLY, SCOTT, MURPHY  
& PRESSER**

# Fax

<b>To:</b>	Examiner: Long Pham Art Unit: 2814	<b>From:</b>	Leslie S. Szivos
<b>Fax:</b>	571-273-8300	<b>Pages:</b>	13 pages including fax cover sheet
<b>Phone:</b>		<b>Date:</b>	3/3/2006
<b>Re:</b>	U.S. Patent Appln. No. 10/662,900 Filed: September 15, 2003 Docket: YOR920030218US1 (16714) Confirmation No. 1278	<b>CC:</b>	

## RESPONSE TO OFFICE ACTION

Please see the following documents:

1. Amendment Transmittal (in duplicate)
2. Authorization to charge IBM deposit account
3. Response under 37 C.F.R. § 1.116 (9 pages)
4. Certificate of transmission by facsimile dated March 3, 2006

If you have any questions concerning this facsimile please contact Vivian Henriquez at 516-742-4343. Thank you.

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## CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)

Applicant(s): Cyril Cabral, Jr., et al.

Docket No.

YOR920030218US1 (16714)

Application No.  
10/662,900- Filing Date  
September 15, 2003Examiner  
Long PhamGroup Art Unit  
2814

Invention: REDUCTION OF SILICIDE FORMATION TEMPERATURE ON SiGe CONTAINING SUBSTRATES

I hereby certify that this

## RESPONSE UNDER 37 C.F.R. § 1.116

(Identify type of correspondence)

is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 571-273-8300)

on March 3, 2006

(Date)

Leslie S. Szivos, Ph.D.

(Typed or Printed Name of Person Signing Certificate)

(Signature)

Note: Each paper must have its own certificate of mailing.

MAR 03 2006

## AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Cyril Cabral, Jr., et al.

Docket No.

YOR920030218US1 (16714)

Application No.  
10/662,900Filing Date  
September 15, 2003Examiner  
Long PhamCustomer No.  
23389Group Art Unit  
2814Confirmation No.  
1278

Invention: REDUCTION OF SILICIDE FORMATION TEMPERATURE ON SiGe CONTAINING SUBSTRATES

## COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

## CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	17	27 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	2	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

Please charge Deposit Account No. in the amount of

A check in the amount of to cover the filing fee is enclosed.

The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

Payment by credit card. Form PTO-2038.

**WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.**

Signature

Dated: March 3, 2006

Leslie S. Szivos, Ph.D.  
Registration No. 39,394  
SCULLY, SCOTT, MURPHY & PRESSER, P.C.  
400 Garden City Plaza, Suite 300  
Garden City, New York 11530

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

(Date)

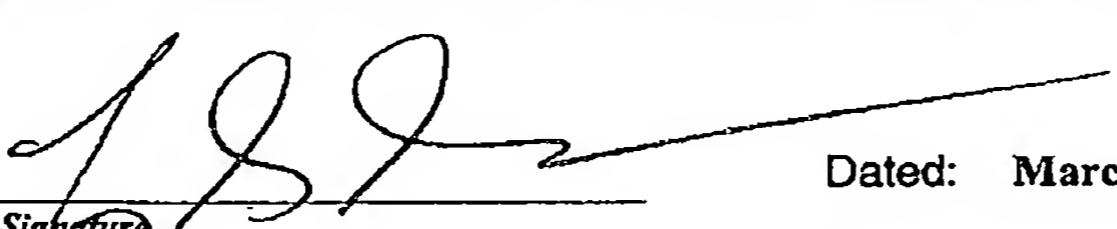
Signature of Person Mailing Correspondence

Typed or Printed Name of Person Mailing Correspondence

CC:

P11LARGE/REV09

MAR 03 2006

AMENDMENT TRANSMITTAL LETTER (Large Entity)				Docket No. YOR920030218US1 (16714)		
Applicant(s): Cyril Cabral, Jr., et al.	Application No. 10/662,900	Filing Date September 15, 2003	Examiner Long Pham	Customer No. 23389	Group Art Unit 2814	Confirmation No. 1278
Invention: REDUCTION OF SILICIDE FORMATION TEMPERATURE ON SiGe CONTAINING SUBSTRATES						
<u>COMMISSIONER FOR PATENTS:</u>						
Transmitted herewith is an amendment in the above-identified application.						
The fee has been calculated and is transmitted as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	17 -	27 =	0	x \$50.00	\$0.00	
INDEP. CLAIMS	2 -	3 =	0	x \$200.00	\$0.00	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00	
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00	
<p><input checked="" type="checkbox"/> No additional fee is required for amendment.</p> <p><input type="checkbox"/> Please charge Deposit Account No. in the amount of</p> <p><input type="checkbox"/> A check in the amount of to cover the filing fee is enclosed.</p> <p><input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM</p> <p><input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16.</p> <p><input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.</p> <p><input type="checkbox"/> Payment by credit card. Form PTO-2038.</p>						
WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.						
 <i>Signature</i> Dated: March 3, 2006						
<p>Leslie S. Szivos, Ph.D.  Registration No. 39,394  SCULLY, SCOTT, MURPHY &amp; PRESSER, P.C.  400 Garden City Plaza, Suite 300  Garden City, New York 11530</p>						
<p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on _____</p> <p>(Date)</p> <p><i>Signature of Person Mailing Correspondence</i></p> <p><i>Typed or Printed Name of Person Mailing Correspondence</i></p>						
CC:						

RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant(s):** Cyril Cabral, Jr., et al.

**Examiner:** Long Pham

**Serial No:** 10/662,900

**Art Unit:** 2814

**Filed:** September 15, 2003

**Docket:** YOR920030218US1 (16714)

**For:** REDUCTION OF SILICIDE  
FORMATION TEMPERATURE ON  
SiGe CONTAINING SUBSTRATES

**Dated:** March 3, 2006

**Confirmation No:** 1278

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

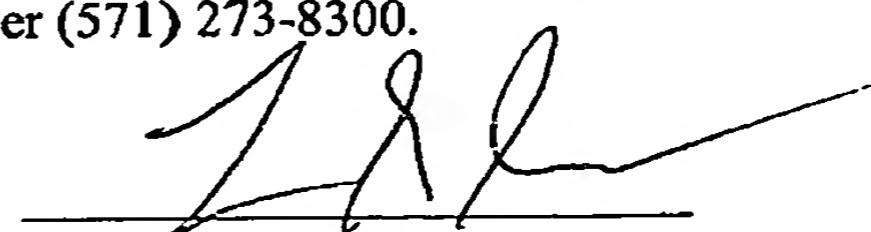
In response to the Office Action dated January 3, 2006, applicants submit the following amendments and remarks for entry into the record of the above-identified patent application.

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CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this document is being filed in the United States Patent and Trademark Office on the date shown below via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 at United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

Dated: March 3, 2006



Leslie S. Szivos